



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG785616121
Report verification at igi.org

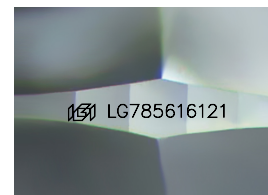
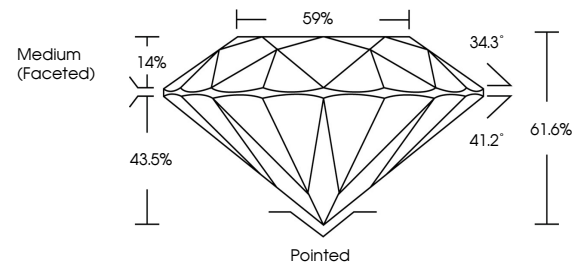
March 30, 2023	
IGI Report Number	LG785616121
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.45 - 7.50 X 4.61 MM
GRADING RESULTS	
Carat Weight	1.59 CARAT
Color Grade	E
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG785616121

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

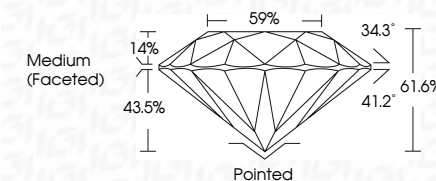
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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March 30, 2026	Carat Weight	1.59 CARAT
GJ Report No. LG7856/1621	Color Grade	E
ROUND BRILLIANT	Clarity Grade	VVS 2
	Cut Grade	IDEAL
	Depth	61.6%
	Table	89%
	Grainle	Medium (Coarsest)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Inscriptions(s)	lgj LG7856/1621

Comments:

This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) process.

Type IIc